

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : David L. Chapek
Serial No. : 09/605,293
Filed : June 28, 2000
Title : SEMICONDUCTOR DEVICES INCLUDING A LAYER OF
POLYCRYSTALLINE SILICON HAVING A SMOOTH
MORPHOLOGY
Docket No. : MIO 0037 VA/40509.118 (96-0831.01)
Examiner : N. Drew Richards
Art Unit : 2815

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

EFS Web Electronic Submission
November 7, 2007

AMENDMENT

This Amendment is being filed in response to the Decision on Appeal decided September 21, 2007, in which new grounds of rejection were entered under 37 CFR §41.50(b). Applicants elect to reopen prosecution and are submitting an appropriate amendment of the rejected claims herewith. Reconsideration and reexamination of the application is respectfully solicited in light of the amendments and remarks below.